

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Sung Soo Si et al. Art Unit : 1792  
Serial No. : 10/595,203 Examiner : DHINGRA, RAKESH KUMAR  
Filed : March 23, 2006 Action Date : May 13, 2008  
Title : PLASMA RAPID THERMAL PROCESS APPARATUS IN WHICH SUPPLY  
PART OF RADICAL SOURCE IS IMPROVED

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Fax: 571-273-8300

**AMENDMENT**

Dear Sir or Madam:

In response to the Office Action of May 13, 2008, please amend the above-referenced application as follows.

**Amendment to Claims** begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper submission.

*The Commissioner is hereby authorized to charge fees, if any,  
or credit any overpayment to **Deposit Account No 50-3566**.*